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CONFIRMATION NO. 9586

<b>SERIAL NUMBER</b> 10/810,634	<b>FILING OR 371(c) DATE</b> 03/29/2004 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2823	<b>ATTORNEY DOCKET NO.</b> 2336-256	
<b>APPLICANTS</b> Ju Hyun Kim, Suwon, KOREA, REPUBLIC OF; Bang Won Oh, Sungnam, KOREA, REPUBLIC OF;  <b>** CONTINUING DATA *****</b> <i>none</i>  <b>** FOREIGN APPLICATIONS *****</b> REPUBLIC OF KOREA 2003-66080 09/23/2003 <i>of 1/1</i>					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 06/07/2004</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>[Signature]</i> <i>[Initials]</i> Examiner's Signature Initials		<b>STATE OR COUNTRY</b> KOREA, REPUBLIC OF	<b>SHEETS DRAWING</b> 9	<b>TOTAL CLAIMS</b> <del>5</del> 20	<b>INDEPENDENT CLAIMS</b> <del>1</del> 3
<b>ADDRESS</b> LOWE HAUPTMAN GILMAN & BERNER, LLP Suite 310 1700 Diagonal Road Alexandria, VA22314					
<b>TITLE</b> Method for separating sapphire wafer into chips using dry-etching					
<b>FILING FEE RECEIVED</b> 970	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		